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# **Optical and structural properties of highly porous shell structured Fe doped TiO<sub>2</sub> thin films**

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**Abstract** TiO<sub>2</sub> thin films with 0.2 wt%, 0.4 wt%, 0.6 wt%, and 0.8 wt% Fe were prepared on glass and silicon substrates using sol–gel spin coating technique. The optical cut-off points are increasingly red-shifted and the absorption edge is shifted over the higher wavelength region with Fe content increasing. As Fe content increases, the optical band gap decreases from 3.03 to 2.48 eV whereas the tail width increases from 0.26 to 1.43 eV. The X-ray diffraction (XRD) patterns for doped films at 0.2 wt% and 0.8 wt% Fe reveal no characteristic peaks, indicating that the film is amorphous whereas undoped TiO<sub>2</sub> exhibits (101) orientation with anatase phase. Thin films of higher Fe content exhibit a homogeneous, uniform, and nano-structured highly porous shell morphology.

**Keywords** Fe; TiO<sub>2</sub>; Porous shell; Sol–gel

## 1 Introduction

The studies on nano-structured wide gap oxide semiconductor thin films attract many researchers due to their distinctive properties such as tailored band gap, with

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Nano-Research for Advanced Materials and Technologies, (Nano-RAM Technologies), Bangalore 560040, Karnataka, India doping, high transparency, and high dielectric constant. These thin films have wide range of applications in protective and antireflective coatings [1, 2], gas sensors [3], thin film capacitors [4], solar collectors and solar cells [5], and inductive devices [6]. Investigations are carried out by several researchers to enhance the optical transmittance with modified parameters of TiO<sub>2</sub> by doping with transition metal ions such as Fe, Nb, Mn, Co, Sn, Cd, and Ni. Among a range of dopant, replacement of iron in the titania model is ideal due to similar size of  $Fe^{3+}$  and  $Ti^{4+}$ . It is an observed fact that, though iron always presents in titanium oxide as an intrinsic impurity, the electrical and optical properties of TiO<sub>2</sub> depend on the concentrations of both intrinsic defects and extrinsic impurities [7]. Oxide films are deposited both by physical (evaporation, sputtering, ion beam) and chemical (chemical vapor deposition, plasma enhanced chemical vapor deposition, spray pyrolysis, and sol-gel) methods [8-10]. Over these deposition methods, sol-gel based spin coating is preferred due to its ease of coating procedure and synthesis. In the present study, effect of Fe doping in TiO<sub>2</sub> on optical, structural, and morphological properties prepared by solgel spin coating on a glass substrate was investigated.

#### 2 Experimental

## 2.1 Sample preparation

Titanium iso-propoxide (Sigma–Aldrich) with purity of 99.99 % and ferric chloride salt (Merck  $\geq$ 98 %) were used as the starting materials for the synthesis of solgel. The systematic process flow of solution preparation is shown in Fig. 1. The substrates used for deposition were degreased in soap water, then ultrasonically cleaned with acetone and



Fig. 1 Process flowchart for preparation and deposition of  $\mbox{Fe}\mbox{-Ti}\mbox{O}_2$  thin films

dried in oven at 100 °C for 15 min. The films were deposited by spin coating at 3,000 r·min<sup>-1</sup> for 60 s. In order to increase the thickness, multiple spin was employed between successive depositions; the films were preheated at 80 °C for 15 min. Finally, obtained thin films were annealed at 200, 400, and 800 °C for 3 h/air ambient.

## 2.2 Characterization

The optical properties of Fe doped TiO<sub>2</sub> films were determined by visible–near infrared spectrophotometer (Ocean Optics, USA). The thickness and refractive index were calculated using transmission spectra by envelope technique [11]. The optical band gap was obtained using Tauc's equation [12, 13] and difference in band gap with respect to doping was determined by extra plotting  $(\alpha hv)^{1/2}$  versus (*hv*). The structural properties of the films were investigated using a Philips X-ray diffractometer (XRD) with monochromatic Cu K $\alpha$  radiation. The film morphology was studied using scanning electron microscopy (SEM, Raith, eLiNE).

#### 3 Results and discussion

# 3.1 Optical properties

The optical properties were studied using optical transmission and reflection spectra in the visible wavelength (350–800 nm) for the films annealed at 400 °C on glass substrates. The optical parameters such as refractive index, absorption coefficient, band gap were analyzed from the



Fig. 2 Spectral transmittance of Fe–TiO<sub>2</sub> thin films annealed at 400  $^{\circ}$ C/3 h/air ambient



Fig. 3 Spectral reflectance of Fe–TiO<sub>2</sub> thin films annealed at 400 °C/ 3 h/air ambient

transmission spectra. The maximum thickness obtained by envelope technique for three multiple coatings is found to be 260 nm. The transmittance spectra of Fe-TiO<sub>2</sub> with different Fe contents on glass substrate are shown in Fig. 2. The spectra reveals that the formation of absorption edge toward higher wavelength region is up to 418 nm (Fig. 3), whereas in pure TiO<sub>2</sub> thin films transmittance quickly decreases below 355 nm indicating the absorption of light induced by the excitation of electrons from the valence band to the conduction band [14]. The 0.2 wt% Fe film exhibits high transmittance (85 %) in visible wavelength and then decreases with consecutive increase in doping concentration. The shift in the transmission edge as doping increases indicates the decrease in band gap of the film. The refractive index of doped TiO<sub>2</sub> thin films is found to be in the range of 2.05 wt%-1.95 wt% for 0.2 wt%-0.8 wt% estimated for half wavelength. Further, the Fe doped TiO<sub>2</sub> thin films are fully



Fig. 4 Band gap of Fe-TiO<sub>2</sub> thin films (Inset variation of lna vs hv)



Fig. 5 Absorption coefficient of  $Fe-TiO_2$  thin films with respect to wavelength

transparent and exhibit distinctive scattering transmittance for the thin films in the visible wavelength. This effect was previously observed by Kim et al. [15].

Figure 4 represents the reflectance properties of Fe doped TiO<sub>2</sub> thin films. It can be noticed that the reflectance is increasingly red-shifted with the increase of doping content. This can be attributed to the charge shift which can be induced between the different valence states of same metal, such as between Fe<sup>2+</sup> and Fe<sup>3+</sup>. Absorptions owing to charge transfer are the main cause of the red color of iron oxides and hydroxides where it is found that the absorption bands rapidly decrease in intensity [16]. Reflectance spectra of iron oxides have such strong absorption bands that the shape changes significantly with grain size. Small shifts in absorption band position are also observed due to substitution of other elements, like aluminum for iron in hematite [17]. The minimum reflectance

**Table 1** Measured values of band gap and tail width of different Fecontents doped  $TiO_2$  thin films

Fe content/wt%	Band gap/eV	Tail width/eV
0.2	3.03	0.26
0.4	2.90	0.75
0.6	2.66	0.88
0.8	2.48	1.43



Fig. 6 XRD patterns of pure TiO<sub>2</sub> and Fe doped TiO<sub>2</sub> thin films

is equal to glass reflectance exhibited by thin films of greater than 0.4 wt% Fe doping content. The minimum reflectance can be attributed to the transformation in morphology toward porous shell. The porous morphology also helps to obtain the minimum reflection due to total internal reflection of light [18].

The optical band gap of the Fe–TiO<sub>2</sub> thin films was estimated by the extrapolation of the linear portion of the  $(\alpha hv)^{1/2}$  versus *hv* plots using the relation,

$$\alpha h v = A \left( h v - E_{\rm g} \right)^{1/2} \tag{1}$$

where hv is the photon energy,  $\alpha$  is absorption coefficient,  $E_{g}$  is the band gap and A is the frequency independent constant. The optical band of Fe-TiO<sub>2</sub> varies depending on the variation of Fe concentration. The measured optical band gap values of the doped TiO<sub>2</sub> films are between 2.48 and 3.03 eV for 0.8 wt% and 0.2 wt% Fe doping, respectively (Fig. 5). The inset of Fig. 5 represents the Urbach tail which signifies the characteristic phenomena of absorption curve with respect to photon energy. If the structure of the film is disorder, it can be estimated the level of disorderness using this Urbach energy [19] which results in lean-in the transmittance spectra toward minimum photon energy. The tail width of the films can be calculated by the slope of the straight line portion of the plot. The optical band gap  $(E_g)$  and the tail width  $(\Delta E)$  of doped TiO<sub>2</sub> films are shown in Table 1. The tail width



Fig. 7 SEM images of Fe-TiO<sub>2</sub> thin film with different Fe contents: a 0.2 wt%, b 0.4 wt%, c 0.6 wt%, and d 0.8 wt%

increases with doping content from 0.26 to 1.43 eV. This increase in tail width is the evidence for the change in crystalline to amorphous porous form of the prepared films with decreased band gap.

## 3.2 Structural properties

The XRD spectra of pure and doped TiO<sub>2</sub> thin films are shown in Fig. 6. The pure and doped  $TiO_2$  and films were annealed at different elevated (200-800 °C) temperatures.  $TiO_2$  film exhibits amorphous nature as there are no characteristic peaks when annealed at 200 °C. As the annealing temperature further increases to 400 and 800 °C, the eminent peak at  $2\theta$  value of 25.33° is obtained corresponding to (101) orientation of the crystalline anatase phase (JCPDS card number 83-2243) and an additional peak at  $2\theta$  value of 36.11° corresponding to (101) orientation of the rutile phase (JCPDS 88-1175), respectively. The grain size calculated using Scherrer's equation for TiO<sub>2</sub> films is found to be 14 nm. The XRD patterns for doped films at 0.2 wt% and 0.8 wt% Fe doping annealed at 400 °C reveal no characteristic peaks, indicating that the film is amorphous. This occurrence caused by the iron doping can dwell in the crystallization of anatase TiO<sub>2</sub>. Wang et al. [20] reported that doping of higher concentration of Fe will inhibit the crystallization of TiO<sub>2</sub>. Even though reported value indicates that  $Fe^{3+}$  doped  $TiO_2$ speeds up anatase transformation to rutile and reduces the initial transition temperature to below 550 °C [21] but in this investigation, the crystallization of TiO<sub>2</sub> is not found for doped TiO<sub>2</sub> thin films calcined at 400 °C for 3 h. This suggests that the inhibition of phase transition is not only by higher doping concentration but also with the change in morphology which is depicted in Fig. 6.

## 3.3 Surface morphology

Surface morphology of 0.2 wt%, 0.4 wt%, 0.6 wt%, and 0.8 wt% Fe doped TiO<sub>2</sub> thin films are shown in Fig. 7. The 0.2 wt% Fe–TiO<sub>2</sub> thin film exhibits uniform, dense, and compact morphology. The further doping of Fe causes change in morphology from smooth surface to porous shell. The 0.8 wt% film has the porosity ranging from 100 to 500 nm.

#### 4 Conclusion

The increase of the iron content in  $\text{TiO}_2$  causes change in structural and morphology of the films. The inhibition in crystallinity is noticed for doped thin films. This is evident from the increased tail width with decreased band gap value. Surface morphology shows the change in highly dense uniform to porous nano-shell structure with the increase of Fe content. Even at higher concentrations, the thin films remain transparent. The results indicate that the low reflectance with porous morphology thin films is well suited for gas sensors and antireflective thin films.

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